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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/662,525	09/16/2003	Minh Van Ngo	50432-642	1701
7590 06/17/2004 McDERMOTT, WILL & EMERY 600 13th Street, N.W. Washington, DC 20005-3096			EXAMINER	
			VU, QUANG D	
			ART UNIT	PAPER NUMBER
			2811	
		DATE MAILED: 06/17/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/662,525	NGO ET AL.				
Office Action Summary	Examiner	Art Unit				
	Quang D Vu	2811				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).						
Status						
1)⊠ Responsive to communication(s) filed on <u>02 June 2004</u> .						
,	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4) Claim(s) 11-20 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) Claim(s) is/are allowed. 6) Claim(s) 11-20 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
9) The specification is objected to by the Examiner.						
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: Certified copies of the priority documents have been received. Certified copies of the priority documents have been received in Application No. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
Attachment(s)						
1) Notice of References Cited (PTO-892)	4) Interview Summary					
 Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date <u>09/16/03</u>. 	Paper No(s)/Mail Da 5) Notice of Informal Pa 6) Other:	ite atent Application (PTO-152)				

DETAILED ACTION

Election/Restrictions

Applicant's election without traverse of group II (claims 11-20) in the reply filed on 06/02/04 is acknowledged.

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 11 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent Application Publication No. 2004/0041264 to Kloster et al. in view of US Patent No. 6,461,675 to Paranjpe et al.

Regarding claim 11, Kloster et al. (figure2-5) teach a semiconductor device comprising: an opening in a dielectric layer (100); and

a composite barrier layer (110) formed on a surface of the dielectric layer lining the opening; wherein the surface of the dielectric layer comprises a nitrogen (N₂)-enriched surface region (Kloster et al. teach tantalum nitride layer [110], which is deposited in an atmosphere of nitrogen; paragraph [0032]); and

Kloster et al. teach the composite barrier layer (110) comprises an initial graded layer of tantalum nitride containing N₂. Therefore, it inherently teaches the composite barrier layer

comprises an initial graded layer of tantalum nitride containing N₂ in an amount decreasing in the direction away from the N₂-enriched surface region.

Kloster et al. teach a tantalum layer (115). Kloster et al. differ from the claimed invention by not showing a layer of alpha-tantalum (α -Ta) on the graded tantalum nitride layer. However, Paranipe et al. teach a layer of alpha-tantalum (column 9, lines 62-65). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teaching of Paranjpe et al. into the device taught by Kloster et al. because it provides an adhesion between two layers. The combined device shows a layer of alpha-tantalum $(\alpha$ -Ta) on the graded tantalum nitride layer.

Regarding claim 18, the combined device differs from the claimed invention by not showing the dielectric layer comprises a dielectric material having a dielectric constant (k) less than about 3.9. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the dielectric layer comprises a dielectric material having a dielectric constant (k) less than about 3.9 because it provides a protection for the under layer from damage. Furthermore, it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

3. Claims 12-17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kloster et al. in view of Paranjpe et al., and further in view of US Patent No. 6,326,301 to Venkatesan et al.

The disclosures of Kloster et al. and Paranipe et al. are discussed as applied to claims 11 and 18 above.

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Regarding claim 12, the combined device differs from the claimed invention by not showing the dielectric layer comprises fluorine (F)-containing silicon oxide derived from F-doped tetraethylorthosilicate (F-TEOS). However, Venkatesan et al. teach F-TEOS dielectric layer (column 5, lines 56-62). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teaching of Venkatesan et al. into the device taught by Kloster et al. and Paranjpe et al. because it protects the under layer from damage.

Regarding claim 13, the combined device shows the nitrogen- enriched surface region contains F in an amount less than the remainder of the dielectric layer.

Regarding claim 14, the combined device differs from the claimed invention by not showing the N₂-enriched region has a thickness of about 10 Angstroms to about 20Angstroms. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the N₂-enriched region has a thickness of about 10 Angstroms to about 20Angstroms, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. In re Aller, 105 USPQ 233.

The combined device differs from the claimed invention by not showing the graded tantalum nitride layer has a thickness of about 20Angstroms to about 50Angstroms. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the graded tantalum nitride layer has a thickness of about 20Angstroms to about 50Angstroms because it protects the under layer from damage. Furthermore, it has been held that where the

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general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. In re Aller, 105 USPQ 233.

The combined device further differs from the claimed invention by not showing the α -Ta layer has a thickness of about 200 Angstroms to about 300 Angstroms. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the α -Ta layer has a thickness of about 200 Angstroms to about 300 Angstroms because it provides an adhesion between two layers. Furthermore, it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. In re Aller, 105 USPQ 233.

Regarding claim 15, the combined device differs from the claimed invention by not showing the nitrogen-enriched region contains about 10 to about 40 at % N₂. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the nitrogen-enriched region contains about 10 to about 40 at % N₂, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. In re Aller, 105 USPQ 233.

The combined device further differs from the claimed invention by not showing the graded tantalum nitride region contains N_2 in an amount of about 5 to about 15 at % proximate the N_2 -enriched region decreasing toward the α -Ta layer. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the graded tantalum nitride region contains N_2 in an amount of about 5 to about 15 at % proximate the N_2 -enriched region decreasing toward the α -Ta layer because it provides a protection for the under layer from damage. Furthermore, it has been held that where the general conditions of a claim are disclosed

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in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. In re Aller, 105 USPQ 233.

Regarding claim 16, the combined device shows the opening is filled with copper (Cu) (Kloster et al.; 120).

Regarding claim 17, the combined device shows the opening is a dual damascene opening comprising a lower via hole in communication with an upper trench; and the filled opening comprises a Cu (Kloster et al.; 120) via in communication with an upper Cu (Kloster et al.; 125).

4. Claim 19 is rejected under 35 U.S.C. 103(a) as being unpatentable over Kloster et al. in view of Paranipe et al., and further in view of US Patent No. 6,265,779 to Grill et al.

Regarding claim 19, the disclosures of Kloster et al. and Paranjpe et al. are discussed as applied to claims 11 and 18 above.

The combined device differs from the claimed invention by not showing the dielectric material is a halogen-containing material. However, Grill et al. teach halogen-containing dielectric (column 4, lines 59-60). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teaching of Grill et al. into the device taught by Kloster et al. and Paranjpe et al. because it reduces sensitivity to wafer resistivity.

5. Claim 20 is rejected under 35 U.S.C. 103(a) as being unpatentable over Kloster et al. in view of Paranjpe et al., and further in view of US Patent No. 6,326,301 to Venkatesan et al.

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Regarding claim 20, the disclosures of Kloster et al. and Paranjpe et al. are discussed as applied to claims 11 and 18 above.

The combined device differs from the claimed invention by not showing the dielectric material is a fluorine (F)-containing oxide. However, Venkatesan et al. teach F-TEOS dielectric layer (column 5, lines 56-62). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teaching of Venkatesan et al. into the device taught by Kloster et al. and Paranjpe et al. because it protects the under layer from damage.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quang D Vu whose telephone number is 571-272-1667. The examiner can normally be reached on Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eddie Lee can be reached on 571-272-1732. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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qv June 10, 2004

Primary Examiner